

**Notice of References Cited**

Application/Control No.

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Applicant(s)/Patent Under  
Reexamination  
LIU, ENHUI

Examiner

OMAR GHOWRWAL

Art Unit

2416

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**U.S. PATENT DOCUMENTS**

*		Document Number	Date	Name	Classification
		Country Code-Number-Kind Code	MM-YYYY		
*	A	US-2007/0005368 A1	01-2007	Chutorash et al.	704/275
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

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	N					
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